

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: P. Loges, et al.

Confirmation No.: 6665

Serial No:

10/074,188

Group Art Unit: 3742

Filing Date:

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Examiner: Fastovsky, Leonid M.

Title:

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Docket No:

56326-041 (IOPL-119)

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AMENDMENT A

TECHNOLOGY CENTER R3700

Sir:

In response to the Office Action mailed June 9, 2003, please amend the above-identified application as follows: